## NOTES:

1. SUBSTRATE: SILICON (SI)

2. SURFACE S2 TO BE PARALLEL TO SURFACE S1 TO WITHIN <10 arcmin

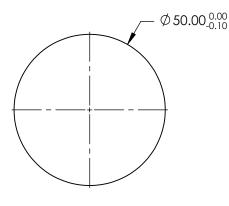
3. TRANSMISSION (%): >85%

4. CUT-ON WAVERLENGTH: 1.05.0µm

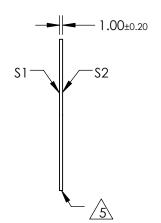
5 FINE GRIND SURFACE

 POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATION APPLY ACROSS CLEAR APERTURE

7. RoHS: COMPLIANT



PARTS TO THIS DRAWING



LONGPASS FILTER

Rev. A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	80-50	80-50
COATING APERTURE	Ø45	Ø45
SURFACE FLATNESS	3 - 5λ	3 - 5λ
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

